PROCEEDINGS OF SPIE

Optical Fabrication and Testing VIII

Eric Ruch Reinhard Völkel Editors

8–10 April 2024 Strasbourg, France

Sponsored by SPIE

Cooperating Organisations
Photonics 21 (Germany)
EOS—European Optical Society

Published by SPIE

Volume 13021

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Please use the following format to cite material from these proceedings: Author(s), "Title of Paper," in *Optical Fabrication and Testing VIII*, edited by Eric Ruch, Reinhard Völkel, Proc. of SPIE 13021, Seven-digit Article CID Number (DD/MM/YYYY); (DOI URL).

ISSN: 0277-786X

ISSN: 1996-756X (electronic)

ISBN: 9781510673601

ISBN: 9781510673618 (electronic)

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA Telephone +1 360 676 3290 (Pacific Time)

SPIE.ora

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Contents

v Conference Committee

OPTICAL FABRICATION AND TESTING I 13021 02 Design and manufacturing of the CHIME spectrometer unit [13021-1] 13021 03 Manufacture and verification of M6C mirrors the pre-focal stations of the ESO-Extremely Large **Telescope** [13021-2] 13021 04 Hyperpolished off-axis optics using nanoparticle slurries: concept and first results [13021-4] **OPTICAL FABRICATION AND TESTING II** 13021 05 Design and manufacturing of a metallic telescope for ground-based quantum communication [13021-6] 13021 06 Active alignment technique of an off-axis beam expander [13021-7] 13021 07 Design and fabrication of aspheric Fresnel-type lenses for solar energy by using a 3D printer [13021-8] 13021 08 Design and fabrication of an off-axis Fresnel-type reflector by using 3D printing [13021-9] **OPTICAL FABRICATION AND TESTING III** 13021 09 Coating stress compensation and temporal evolution studies for ion beam sputtered thin films [13021-11] 13021 0A Effect of the skew ray error on corneal topography using a cone topographer [13021-13] 13021 OB Design of a planar off-axis null-screen for characterization of a concave surface used in a seismic isolation device [13021-14] 13021 0C Different refracted wavefront approaches propagated through an achromat separated doublet [13021-15]

OPTICAL FABRICATION AND TESTING IV

	OF IICAL FABRICATION AND TESTING IV
13021 0D	Optical testing of a high numerical aperture spherical mirror [13021-16]
13021 OE	Development of an interferometric test bench for the manufacturing of the ELT secondary mirror [13021-17]
13021 OF	Development of a 18 point active supporting tool for the metrology of the ELT M2 secondary mirror [13021-18]
13021 0G	Extension of an optical coordinate measurement machine with a tactile probe, for combined measurement of optical surfaces and mechanical reference features [13021-19]
	OPTICAL FABRICATION AND TESTING V
13021 0H	Design, simulation, and verification of a radially supported 60 inch meniscus mirror in a horizontal line of sight [13021-20]
13021 01	Deep ultraviolet spectral photometry investigation of optical components under vacuum and nitrogen purge conditions [13021-24]
	OPTICAL FABRICATION AND TESTING VI
13021 OJ	Performance of UV-molded versus injection molded maskless microlens arrays for multi-aperture projection [13021-25]
	POSTER SESSION
13021 OK	Fabrication of diffraction gratings using sol-gel method and imprinting method [13021-23]
13021 OL	Development of a long cone corneal topographer to evaluate corneas without symmetry of revolution [13021-31]
13021 OM	Precision inspection of micro-components surfaces by moiré interferometry [13021-32]
13021 0N	Null-screen based corneal topography using a smartphone [13021-33]
	DIGITAL POSTER SESSION
13021 00	Realization of a cost-effective 3D-printed lens for aberration correction for visible spectrum imaging [13021-35]